



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

: **Confirmation No. 5731**

Akihisa HONGO et al.

: Attorney Docket No. 2001_0133A

Serial No. 09/762,582

: Group Art Unit 1753

Filed April 12, 2001

: Examiner Arun Phasge

SUBSTRATE PLATING
METHOD AND APPARATUS

Mail Stop: Amendment

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Sir:

Petition hereby is made for a two month extension of time to respond to the communication of

June 10, 2005.

The fee of \$450.00 is

(X) submitted herewith.

() to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is enclosed.

() Small entity status of this application is established by a Small Entity Status Assertion which

() is enclosed.

() has been previously submitted.

Respectfully submitted,

Akihisa HONGO et al.

11/14/2005 SZEWDIE1 00000035 09762582

01 FC:1252

450.00 DP

By

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November 10, 2005